Van der Waals Epitaxial Double Heterostructure: InAs/Single-Layer Graphene/InAs

Young Joon Hong,* Jae Won Yang, Wi Hyoung Lee, Rodney S. Ruoff, Kwang S. Kim,* and Takashi Fukui

Weak van der Waals (vdW) interactions have recently ignited diverse practical device applications, including heterojunction electronics,[1] mechanically transferrable optoelectronics,[2] and bio-molecular electronic devices.[3] Among the various materials for these applications, graphene offers an ideal material model for vdW interactions, because its carbon honeycomb monoatomic layer (with sp² hybridization) has no permanent polarity or surface dangling bonds (unpaired electrons). However, due to the chemical inertness of graphene,[4] fabrication of epitaxial semiconductor/graphene heterostructures has been difficult, with only very limited reactions for chemical binding, such as epitaxial oxidation.[5] Graphene-based vertical heterostructure devices, therefore, have been mostly fabricated by layer-by-layer stacking,[3] producing heterojunctions with random crystallographic orientations to the graphene lattices. This stacking technique has provided an important opportunity for high-performance graphene-based devices. Less layer–layer coupling at the heterojunction has only a slight effect on the sublattice symmetry; thus, this approach preserves the intrinsic properties of graphene and its high carrier mobility.[1,6] Due to the feasibility of large-scale synthesis of graphene[7] and monolithic integration of inorganic materials on graphene,[8] these promising heterostructure devices are now readily open to scale-up heteroepitaxial fabrication.

Koma et al. proposed that the vdW attractions can be exploited for heteroepitaxy on arbitrary substrates.[9] More importantly, vdW heteroepitaxy can be used to integrate a variety of inorganic materials on diverse substrates.[10] Recently, graphene was used as a substrate for semiconductor epitaxy by means of the vdW heteroepitaxy.[11] Specifically, because the vdW epitaxy yields an abrupt heterointerface with less electronic coupling, due to noncovalent bonding, it is surmised that the technique can provide a straightforward monolithic integration method for high-quality epitaxial semiconductor/graphene vertical heterostructures. For the graphene-based vertical multi-heterostructures, sequential direct vdW heteroepitaxy for each layer is necessary.[12] However, the high growth temperature required for the direct vdW epitaxy of graphene,[13] as well as the growth interruption for etching of the metal layer, limits the effectiveness and efficiency of microelectronic processing. Thus, there remains the challenge of developing new methods for fabricating the multi-heterostructures. To overcome these obstacles, we used suspended graphene substrates and the vapor-phase transport-based vdW epitaxy technique. In this communication, we demonstrate successful fabrication of epitaxial InAs/graphene/InAs double heterostructures, which is explained based on first-principle calculations.

Our promising approach to monolithically integrated graphene-based vertical double heterostructures is to grow InAs nanostructures on both sides of suspended single-layer graphene (S-SLG), using metal–organic vapor-phase epitaxy (MOVPE). For S-SLG substrate preparation, SLG films were synthesized by chemical vapor deposition (CVD)[14] and transferred onto the SiN₄ membrane/Si substrates by etching–transfer techniques. The thickness of the S-SLG films was evaluated using micro-Raman spectroscopy (Supporting Information, Figure S1). The SiN₄ membrane, with perforated hole arrays, was designed to support the S-SLG. Surface morphological inspection and microstructural analyses were performed by field-emission scanning electron microscopy (FESEM), high-resolution transmission electron microscopy (HRTEM), and atomic resolution scanning-TEM (STEM) with energy-dispersive X-ray spectroscopy (EDX). First-principles total energy, vdW binding energy, and electronic structure calculations were carried out using vdW-density functional (DF) method. Detailed descriptions of the experiments and theoretical calculations are given in Supporting Information.

The combined vdW–MOVPE yielded InAs nanostructures on both sides of S-SLG. Figure 1a illustrates the vapor-phase transport process for the vdW–MOVPE of InAs on/underneath the S-SLG. Low-pressure and high gas velocity transport conditions...
of 76 Torr and 0.8 m s\(^{-1}\), respectively, were used to promote rapid diffusion of precursors across the thin boundary layer (δ ∝ \(u_0^{-1/2}\) in the Blasius solution, where δ is the boundary layer thickness, and \(u_0\) is the free-stream velocity).\(^{[15]}\) The precursor afflux by diffusion enabled the growth of InAs on the backside of the S-SLG, with two possible diffusion-supply pathways: (i) through the gap between the substrate and the susceptor, and/or (ii) through the perforated holes in the membrane not covered with the S-SLG, as illustrated in Figure 1a.

The S-SLG was transparent enough to examine the InAs nanostructures formed on the backside of S-SLG under normal brightness and contrast conditions for SEM (Figure 1b–e, non-colored SEM images are also given in Figure S2). The FESEM images of Figure 1b and c show that vertically well-aligned InAs nanowires and nanoislands formed on both S-SLG and SLG/SiNx, with a homogeneous six-fold rotational in-plane alignment, signifying that S-SLG, a free-standing ultrathin monoatomic layer, can provide sufficient vDW attractions for heteroepitaxy. Some of the nanoislands, however, had no hexagonal rotational symmetry, presumably due to multi-nucleations resulting in polycrystallinity at around grain boundary of the SLG. Because the nanostructures that formed underneath the S-SLG (red- and violet-colored objectives in Figure 1a) were smaller than those on the front side (Table S1), due to the low precursor concentration at the backside of S-SLG (\(C_F > C_B\) in Figure 1a), further SEM inspection was performed on the backside of S-SLG. Figure 1d clearly shows high-density InAs nanostructures (∼5.5 × 10\(^8\) cm\(^{-2}\)) formed on the backside of S-SLG, whose number density was comparable to that on the front side of the S-SLG (∼5.9 × 10\(^8\) cm\(^{-2}\)). The number density values for the nanostructures are given in Figure 2. The number density values of respective nanostructures were the same within acceptable error ranges, irrespective of the substrate area, implying that the precursor concentration did not affect the heterogeneous nucleation density of InAs on either side of the S-SLG under vDW–MOVPE conditions but determined the mean size values of the nanostructures (Table S1). The same number density values resulted presumably from the same density of atomic ledges (or interplanar vacancies) on both the front and back of S-SLG.

The high-density formation of InAs nanostructures on both sides of S-SLG yielded InAs/SLG/InAs double heterostructures, in which the InAs crystals were diametrically grown at the same position on both sides of S-SLG (Figure 1d and e). The total number density of the double heterostructures was 3.2 × 10\(^8\) cm\(^{-2}\), which is half that of InAs nanostructures on S-SLG, indicating high yield (Figure 2a and c). The double heterostructures can be classified into nanowire/SLG/nanowire, nanoisland/SLG/nanowire, and nanoisland/SLG/nanoisland, in terms of morphology (Figure 1e). The nanostructures in these double heterostructures also exhibited an identical hexagonal in-plane alignment (SEM images in Figure 1e), attributable to the excellent lattice and symmetry match between InAs and graphene. Meanwhile, the InAs nanostructures on SLG/SiNx exhibited little difference in number density, compared with those on S-SLG (Figure 2); this indicates that the amorphous

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**Figure 1.** vDW–MOVPE growth of InAs nanostructures on/underneath S-SLG. (a) Schematic illustrations displaying InAs nanostructures grown on both sides of a S-SLG substrate by vDW–MOVPE. (b–e) FESEM images of the InAs nanostructures grown on S-SLG, taken from the front side (b, tilt-view; c, plan-view) and the backside (d, tilt-view; e, plan-views) of the membrane. The yellow (i) and green (ii) colors in (b–e) correspond to InAs nanowires and nanoislands formed on the front side of S-SLG, respectively; the red (iii) and violet (iv) colors are nanowires and nanoislands formed underneath the S-SLG, respectively. The red circles and violet boxes in (c) indicate nanowires and nanoislands formed on the backside of S-SLG, respectively, seen through the S-SLG. Dotted-line boxes in (d) highlight the InAs/s-SLG/InAs double heterostructures depicted in (e).
layers underneath the SLG provided little electrostatic attraction across the SLG films for forming InAs nanostructures, but the SLG significantly contributed to the epitaxy of InAs with sufficiently strong vdW force.

The crystallographic growth direction of InAs nanostructures grown by the vdW–MOVPE was investigated by cross-sectional high-angle annular dark-field (HAADF) STEM and EDX analyses. Figure 3a shows atomic resolution HAADF-STEM tomography and an EDX atomic-column mapping image recorded for an InAs nanowire, which reveal that the nanowire is composed of a zinc-blende/wurtzite (ZB/WZ) mixture, similar to the microstructure of the nanowire grown by both conventional catalyst-free and metal-catalyst-assisted MOVPE. Despite the high-density stacking faults in the nanowires, the As-polarized [111]ZB or [001]WZ growth direction was maintained along the entire length. Analogously, single-crystalline InAs nanoislands exhibited the same trend of preferred crystallographic growth direction along [111]ZB (Figure 3b). It is noted that the nanoislands are typically single-crystalline ZB in structure with a remarkably reduced density of stacking faults or polytypism, presumably due to the size-dependent thermodynamic stability of the compound semiconductors. e.g., III–V nanowires grown by covalent epitaxy and II–VI nanoarchitectures grown via vdW epitaxy. Cross-sectional STEM investigations revealed the formation of InAs nanostructures along the As-exposed direction, perpendicular to the surface of SLG; this suggests that the InAs/S-SLG/InAs double heterostructures exhibited polarity inversion at the vdW heterointerface, as schematically shown in Figure 3c.

It is necessary to determine how InAs nanostructures form exclusively along the As-terminated direction epitaxially on non-polar SLG. Plan-view TEM analyses of selected-area electron diffraction (SAED) patterns revealed a heteroepitaxial relationship of ZB-InAs ([111]ZB)[001]ZB or WZ-InAs (001)WZ||SLG (001)Si (Figure S3–S4). Considering the degree of semiconductor/graphene lattice mismatch, InAs/S-LG heterostructure must satisfy one of three plausible binding sites for both In and As atoms on graphene: (i) on a hollow (‘H’), which is the center of the carbon honeycomb, (ii) on top (‘T’), directly above a carbon atom, or (iii) at the midpoint of the carbon–carbon bond bridge (‘B’) (Figure 3d). This suggests that the adsorption energy difference between In and As adatoms plays a crucial role in determining the crystallographic growth direction of InAs at the initial growth stage. According to atomic-resolution STEM analysis, the In atoms appeared to have been incorporated into the SLG surface, prior to the As atoms. Chan et al. reported that In adatoms favorably occupy the ‘H’ sites for substantial energy savings, with higher coordination; this is in good agreement with our theoretical calculations. On the ‘B’ sites, the adsorption energy of In–SLG (−0.75 eV at equilibrium distance of 2.5 Å) was calculated to be much lower than that of As–SLG (−0.13 eV at equilibrium distance of 3.0 Å), suggesting that the initial bottom layer of In atoms, positioned close to the SLG, is energetically stable.

The vdW heterointerface was further explored using first-principles energy and electronic structure calculations. Based on the STEM analyses, we assumed that InAs nanostructures grow along ZB[111]B direction normal to the graphene surface. Not only for InAs(111)A free surface but also for the vdW epitaxial InAs(111)/SLG heterostructure, the total energy values of reconstructed interface (and surface) with In vacancy were calculated to be lower than those of unreconstructed, suggesting that the existence of an In vacancy in each (2 × 2) InAs(111)A surface is energetically preferable: the total energy of the (2 × 2) InAs(111)A surface with In vacancy ( = E_{\text{in}}) is lower than that of clean InAs (111)A ( = E_{\text{adh}}) by 1.151 eV, the total energy for the InAs(111)/SLG reconstructed with In vacancy ( = E_{\text{interface}}) is lower than that of unreconstructed heterointerface ( = E_{\text{interface}}) by 0.931 eV for the heterointerface (total energy values are given in Table 1). Using ab initio thermodynamic calculations, the surface Gibbs free energy of the reconstructed InAs(111)/SLG heterointerface with In vacancies (G = E_{\text{interface}} – (N_{\text{In}}−1)\mu_{\text{In}} − N_{\text{As}}\mu_{\text{As}} − N_{\text{C}}\mu_{\text{C}}) was calculated to be lower than that of the non-reconstructed heterointerface.
In–As configuration, the reconstructed initial (111)A bottom layer is compatible with the non-polar graphene surface, in terms of its electron orbital hybridization. Importantly, because not only In atoms, but also As atoms, in the flatly reconstructed (111)A interface contributed to the stronger vdW attractions, the reconstructed binding energy (64 meV) was calculated to be ≈1.5 times as great as the non-reconstructed one (46 meV) (Table S2). A comparison of the total energy values for the heterointerface indicates the preference of the flatly reconstructed (111)A heterointerface formation. On top of the initial (111)A interfacial layer, InAs (111) layers are stacked along the [111]B direction with sp³-bonds during the MOVPE process; this further confirms the formation of InAs nanostructures along the ZB [111]B direction normal to the graphene surface.

\( G = E_{\text{interface}} - N_{\text{In}}\mu_{\text{In}} - N_{\text{As}}\mu_{\text{As}} - N_{\text{C}}\mu_{\text{C}} \), indicating that InAs(111)A interfaced to the SLG prefer to form the In vacancies for energy minimization (detailed descriptions of the calculations are given in Supporting Information). The theoretically-simulated vdW heterointerfacial atomic configurations are displayed in Figure 4a and b, presenting the vdW epitaxial InAs/SLG heterointerface with an In vacancy. The interfacial layer clearly shows that the As atoms near the In vacancy are intensely strained along the \(-z\) direction for structural relaxation, so-called III–V vacancy buckling\(^{22}\) verified by reflection high-energy electron diffraction and scanning tunneling electron microscopy for clean InAs (111)A surfaces under free surface vacuum conditions.\(^{23}\) Because the flatly reconstructed InAs interfacial layer with an In vacancy has much less polarity along the z-direction than bulk InAs with a zigzag (111)In–As configuration, the reconstructed initial (111)A bottom layer is compatible with the non-polar graphene surface, in terms of its electron orbital hybridization. Importantly, because not only In atoms, but also As atoms, in the flatly reconstructed (111)A interface contributed to the stronger vdW attractions, the reconstructed binding energy (64 meV) was calculated to be ≈1.5 times as great as the non-reconstructed one (46 meV) (Table S2). A comparison of the total energy values for the heterointerface indicates the preference of the flatly reconstructed (111)A heterointerface formation. On top of the initial (111)A interfacial layer, InAs (111) layers are stacked along the [111]B direction with sp³-bonds during the MOVPE process; this further confirms the formation of InAs nanostructures along the ZB [111]B direction normal to the graphene surface.

Table 1. Total energy values for vdW epitaxial InAs/SLG heterostructures.

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<th>Clean InAs (111)A surface</th>
<th>InAs (111)/SLG heterointerfaces(^{\text{b)}})</th>
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<td></td>
<td>Reconstruction with In vacancy in each (2×2) of InAs (111)A(^{\text{a)}})</td>
<td>No vacancy (no reconstruction)</td>
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<tr>
<td>Total energy</td>
<td>–41.726 (≈E_{\text{InAs}})</td>
<td>–40.572 (≈E_{\text{InAs}})</td>
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<td>vdW binding potential</td>
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The energy values are given in eV unit. \(^{\text{a)}}The reconstructed InAs (111)A surface (or interface) has almost flaten In–As configuration with an In vacancy in every (2×2) supercell; \(^{\text{b)}}The bottommost layer of the heterostructure is InAs (111)A.
The diamond-shaped domain in (b–e) corresponds to the supercell of InAs(111)–(2×2) (or the graphene(001)–(2×√3)) surface. Only the lowest monolayer of InAs is shown in (b). Isolines in (d) and (e) are plotted at every 0.001 e Å⁻³, and (d,e) contour maps of CDD calculated at a distance of ±1.55 Å from the SLG surface, as marked in (a). The diamond-shaped domain in (b–e) corresponds to the supercell of InAs(111)–(2×2) (or the graphene(001)–(2×√3)) surface. Only the lowest monolayer of InAs is shown in (b). Isolines in (d) and (e) are plotted at every 0.001 e Å⁻³, and (d,e) contour maps of CDD calculated at a distance of ±1.55 Å from the SLG surface, as marked in (a).

We also investigated the equilibrium vdW heterointerface gap and the vdW binding potential as a function of gap distance. The equilibrium vdW distance was examined by both HRTEM and vdW–DF calculations. Figure 5a shows a cross-sectional HRTEM image of the vdW heterointerface gap (=0.31-nm separation), whose spacing is distinct from d_{002} of graphite (=0.34 nm) and d_{111} (=0.35 nm) of ZB InAs. Statistically, the equilibrium gap exhibited a narrow normal distribution, having a standard deviation of ±0.02 nm (Figure 5b). The energy diagram (Figure 5c) shows that the vdW binding energy has a maximum of 64 meV per carbon atom at the equilibrium heterointerface gap of 3.1 Å for the InAs/SLG heterostructure. The vdW gap of 3.1 ± 0.2 Å (Figure 5b) corresponds to a vdW binding energy of 61–64 meV in the potential diagram, implying homogeneous vdW binding over the entire heterointerface. Such a narrow, homogeneous vdW gap is attributed to maximized vdW cohesion, resulting from a flatly reconstructed InAs/SLG heterointerface with excellent commensuration. The vdW heteroepitaxial binding energy of InAs/SLG was calculated to be greater than the interplanar vdW binding energy of graphite (24–35 meV) obtained by experiments and theoretical calculations, indicating that the quasi-vdW heterointerface bonding is much stronger than the vdW homoeopitaxial bonds. It is remarkable that the strong ‘polar–nonpolar’ quasi-vdW heteroepitaxy system of InAs/SLG broke the smallest limit of the interplanar vdW distance of grapheme–graphene in graphite (3.4 Å).

Figure 4. Electronic structure of the vdW epitaxial InAs/SLG heterointerface at equilibrium. (a) Molecular structures and CDD isosurfaces at the periphery of the vdW epitaxial InAs/SLG heterointerface. The red and blue CDD isosurfaces are contoured at the level of ±0.005 e Å⁻³, signifying electron accumulation and depletion, respectively. Plan-view of (b) atomic configuration of the epitaxial InAs(111)A/graphene heterointerface, (c) CDD isosurface map with an isovalue of ±0.005 e Å⁻³, and (d,e) contour maps of CDD calculated at a distance of ±1.55 Å from the SLG surface, as marked in (a). The diamond-shaped domain in (b–e) corresponds to the supercell of InAs(111)–(2×2) (or the graphene(001)–(2×√3)) surface. Only the lowest monolayer of InAs is shown in (b). Isolines in (d) and (e) are plotted at every 0.001 e Å⁻³. The electronic structure mapped by CDD represents the vdW binding feature with less electron orbital hybridization. 

We further investigated the vdW binding energy for the epitaxial InAs/SLG/InAs double heterostructures. As presented in Figure 5c, the vdW binding potential of the double heterostructure was almost the same as that for the single heterostructure: the binding energy of InAs/SLG–InAs was calculated to be 66 meV per carbon atom at the equilibrium heterointerface gap of 3.1 Å for the double heterostructure. This implies that the backside of the SLG, facing away from the InAs nanostructure of the opposite side by 6.2 Å, is hardly affected by the InAs of front side, due to quite weak vdW attraction at the distance. Because there is little charge transfer from/into the front side, due to quite weak vdW attraction at the distance. Therefore, we presume that the InAs/graphene is a nearly coherent (or nearly commensurate) vdW epitaxial type in the incommensurate regime. Importantly, not only the nearly commensurate vdW epitaxy in this study but also the incommensurate vdW epitaxy yielded clean and abrupt heterointerfaces and high quality monocrystalline overlayers with no threading dislocations, all of which are a significant feature of vdW heteroepitaxy.

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Noticeably, despite the strong vdW heterointerface cohesion, no threading dislocations were observed at the abrupt heterointerface (Figure S5), presumably due to the sufficient stress relaxation through the noncoherent heterointerface. The vdW heteroepitaxy has great advantages for incommensurate heteroepitaxy with large lattice misfits because noncoherent heterointerfaces can effectively release the interfacial stress through the weakly-bound vdW heterojunctions. Hence, this noncoherent epitaxial feature enables to fabricate high quality epitaxial overlayers with suppressed threading dislocation density. Since the vdW heteroepitaxial systems with lattice misfits are under the incommensurate regime (homoepitaxial vdW structures are commensurate type), the InAs/graphene heterostructure is an incommensurate type. It is notable that no plural epitaxial relationships were observed in the plan-view TEM analysis since the InAs/graphene heterostructures have very small lattice misfit (=0.47%). Therefore, we presume that the InAs/graphene is a nearly coherent (or nearly commensurate) vdW epitaxial type in the incommensurate regime. Importantly, not only the nearly commensurate vdW epitaxy in this study but also the incommensurate vdW epitaxy yielded clean and abrupt heterointerfaces and high quality monocrystalline overlayers with no threading dislocations, all of which are a significant feature of vdW heteroepitaxy.

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As mentioned above, the vdW attraction enables the polarity inversion from the vdW heterojunction in the InAs/SLG/InAs...
Double heterostructures. It is well known that polarity inversion is expected when inserting a few nm-thick epitaxial metal or non-polar material layers during the growth of ZB or WZ crystal; this thick layer screens the electric field from the electric dipoles, whose heterointerfacial atoms are all connected by sp³ bonds. In contrast, in our quasi-vdW epitaxial system, the sp² hybrid orbital of SLG does not interact with the sp³ bonds of InAs at the heterojunction in terms of chemical binding. Thus, even such an ultrathin conductive graphene layer (~0.35-nm thickness) facilitates the polarity inversion for sp³/sp²/sp³-type double heterostructures. Due to the decoupled chemical binding of the vdW epitaxy, the monoatomic layered substrates were not accompanied by antiphase heteroepitaxial structures, frequently observed in GaAs/Ge/GaAs double heterostructures with nonoctet-binding heterointerfaces. This clarifies why single-domain (or single-crystalline) InAs nanostructures are easily obtained at the vdW heterojunctions, regardless of the graphene thickness (Figure S5).

In summary, a new approach for fabricating vdW epitaxial semiconductor/graphene double heterostructures was demonstrated using chemical vapor-phase transport-based vdW epitaxy of semiconductors on both sides of suspended graphene substrates. Electron microscopy investigations exhibited that the epitaxial formation of high-density InAs nanostructures on/underneath S-SLG resulted in the formation of InAs/SLG/InAs double heterostructures. Theoretical results from our first-principles calculations revealed that even though the double heterostructures possessed opposite polarizations (upward and downward), the vdW attraction was sufficiently strong and energetically favorable for epitaxial InAs/S-SLG/InAs double heterostructure formation. Additionally, a charge-screening effect was produced by conductive graphene due to noncovalent epitaxy. This quasi-vdW epitaxial system readily offers opportunities for the doping effect investigations for functional device applications. For fabricating exclusively the epitaxial nanowire/SLG/nanowire with desired spatial arrangements, the unwanted nanosiland formations should be suppressed by exploiting the selective-area vdW heteroepitaxy. We believe that this straightforward monolithic integration method for aligned crystallographic stacking will provide a new pathway for unconventional devices.

Figure 5. vdW gap of InAs/SLG heterostructures. (a) Cross-sectional HRTEM lattice image showing the InAs/graphene heterointerface gap. (b) Histogram of the InAs/SLG heterointerface gap, measured by HRTEM analyses. (c) vdW binding energy curves plotted as a function of the vdW gap for epitaxial InAs/SLG heterostructure and InAs/SLG/InAs double heterostructure, calculated by the vdW–DF method.
Supporting Information

Detailed descriptions for the experiments and theoretical calculations are given. Raman spectra of S-SLG substrates (S1), non-colored FESEM images (S2), plan-view TEM (S3), simulated SAED analyses (S4), and cross-sectional HRTEM images of InAs/SLG heterostructures (S2) are also included. Supporting Information is available from the Wiley Online Library or from the author.

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